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KARPAGAM ACADEMY OF HIGHER EDUCATION

Coimbatore-641021. (For the candidates admitted from 2016 onwards)

DEPARTMENT OF PHYSICS

UNIT I (Objective Type/Multiple choice Questions each Questions carry one Mark)

NANOMATERIALS AND APPLICATIONS

S.No.	QUESTIONS	opt1	opt2	opt3	opt4	ANSWER
	Nanotechnology was brought into day light by					
1	delivering lectures by:	Feymann	Einstein	Newton	Max Planck	Feymann
		French word		Spanish word	Latin word	
		meaning	Greek word	meaning	meaning	
2	The prefix "nano" comes from a	billion	meaning dwarf	particle	invisible	Greek word meaning dwarf
	Who first used the term nanotechnology and	Richard	Norio	Eric Drexler,	Sumio Iijima,	
3	when?	Feynman, 1959	Taniguchi, 1974	1986	1991	Norio Taniguchi, 1974
					Concrete	
					nanoparticle	
			Nickname for		with a	
			Mercedes-	Plastic	compressive	
			Benz's futuristic	explosives	strength of 20	
		A carbon	concept car	nanoparticle	nanonewtons	
4	What is a buckyball?	molecule (C60)	(C111)	(C4)	(C20)	A carbon molecule (C60)
	Richard Feynman is often credited with					
	predicting the potential of nanotechnology.	There is a tiny	Things get	Bottom?	There is plenty	
	What was the title of his famous speech given	room at the	nanoscopic at	What	of room at the	There is plenty of room at
5	on December 29, 1959?	bottom	the bottom	bottom?	bottom	the bottom
	Which of these consumer products is already			Sunscreen		
6	being made using nanotechnology methods?	Fishing lure	Golf ball	lotion	All of the above	All of the above

					A software tool	
		A new material			to measure and	
		made from	A one-atom	Thin film	graphically	
		carbon	thick sheet of	made from	represent	A one-atom thick sheet of
7	What is graphene?	nanotubes	carbon	fullerenes	nanoparticles	carbon
	What is the 2017 budget for the U.S. National					
8	Nanotechnology Initiative?	\$587 million	\$917 million	\$1.4 billion	\$2.1 billion	\$1.4 billion
	In which of the following the atoms do not	Shape memory				
9	move from each other?	alloys	Nano materials	Dielectrics	Static materials	Nano materials
10	$10 \text{ nm} = ___ \text{m}$	10-8	10 ⁻⁷	10-9	10-10	10 ⁻⁸
11	The diameter of hydrogen atom is	1	10	0.1	0.01	0.1
	Carbon atoms make type of bond with					
12	other carbon atoms.	covalent	ionic	metallic	hydrogen	covalent
	Fullerene or bucky ball is made up of					
13	carbon atoms.	100	20	75	60	60
14	$1 m = \ nm.$	10-9	10-8	109	108	109
	"There is plenty of room at the bottom."		Richard	Sumio	Richard	
15	This was stated by	Eric Drexler	Feynmann	Tijima	Smalley	Richard Feynmann
			Richard	Sumio	Richard	
16	Who coined the word 'nanotechnology'?	Eric Drexler	Feynmann	Tijima	Smalley	Eric Drexler
	According to the definition by CRN,	mechanical	atomic	Newtonian	micro-	
17	nanotechnology is	engineering	engineering	mechanics	electronics	atomic engineering
	Nanoscience can be studied with the help	quantum	Newtonian	macro-		
18	of	mechanics	mechanics	dynamics	geophysics	quantum mechanics
	Greeks and Romans had used nanoparticles	cosmetics				
19	in the manufacture of	for eyes	medicines	metal articles	hair-dye	hair-dye
	Egyptians were using to prepare	nanoalumini				
20	make-up for eyes.	um	nanocopper	nanosteel	nanolead	nanolead
				Damascus		
21	The sword of Tipu Sultan was made of	nanolead	nanoaluminium	steel	Pure iron	Damascus steel
	contains nanoparticles prepared by	Homeopathi	Modern	Ayurvedic	Modern	
22	using biologically processed metal ores.	c medicines	antibiotics	'Bhasmas'	cosmetics	Ayurvedic 'Bhasmas'
23	The diameter of human hair is nm.	50,000	75,000	90,000	1,00,000	50,000

24	The diameter of human hair is m.	5 x 10 ⁻⁸	5 x 10-7	5 x 10-6	5 x 10-5	5 x 10-5
25	The cut-off limit of human eye is nm.	2,000	5,000	10,000	50,000	10,000
26	The size of E.Coli bacteria is nm.	2,000	5,000	50	90	2,000
27	The size of RBC isnm.	50	90	2,000	5,000	5,000
28	The thickness of a transistor is nm.	50	90	2,000	5,000	90
29	The size of a virus is nm.	2	20	50	2000	50
30	The diameter of a bucky ball isnm.	1,000	100	10	1	1
31	The width of a typical DNA molecule is nm.	1	2	5	10	2
32	1 micrometer (micron) = m.	10-9	10-8	10-7	10-6	10-6
33	1 micrometer (micron) = nm.	1,000	100	10	0.01	1,000
	The surface area to volume ratio of a sphere with radius 1 cm is R_1 and that of a sphere					
34	with radius 5 cm is R_2 . Then $R_1 = R_2$.	3	0.3	5	1/5	5
	The surface area to volume ratio of a cube with side 1 unit is R_1 and that of a cube with					
35	side 10 units is R_2 . Then $R_2 = \R_1$.	0.1	10	1/100	100	0.1
36	The two important properties of nanosubstances are	pressure and friction	sticking and friction	sticking and temperature	temperature and friction	sticking and friction
37	With the help of, Robert F. Curl and others discovered fullerene.	electron microscope	magnetic resonance	condensation technique	mass spectrograph	mass spectrograph
20	In the structure of fullerene each carbon atom forms covalent bonds with other			.1		
	Carbon atoms.	one	two Duoleminator	Diabard	Iour	three
30	dome structure?	Eric Drexler	Fuller	Smalley	Faraday	Buckminster Fuller
	The largest cluster of carbon atoms in Bucky balls known till today consists of				- i urutu y	
40	carbon atoms.	60	75	180	540	540
41	The smallest cluster of carbon atoms in	75	60	20	15	20

	Bucky balls known till today consists of					
	carbon atoms.					
	The tensile strength of an MWNT is					
42	Pa.	63 x 10 ⁶	63 x 107	63 x 108	63 x 109	63 x 109
	The compressive strength of a nanotube				may be greater	
43	its tensile strength.	is less than	is greater than	is equal to	than	is less than
	The hardness of a standard SWNT is					
44	Pa.	63×10^6	25 x 106	25 x 109	25 x 10-9	25 x 109
	The bulk modulus of a standard SWNT is				less than or	
45	that of diamond.	less than	greater than	equal to	equal to	greater than
	How much current can be passed through 1					
46	cm ² cross-section of a metal nanotube?	10 ⁻⁹ A	109 A	1000 A	0.001 A	109 A
47	The size of a quantum dot is nm.	5	10	50	100	5
	The capacity of a normal human eye to see the					
48	smallest object is µm.	10000	1000	100	10	10
	Nanoparticles of which substance were found					
49	on the surface of the sword of Tipu Sultan?	Gold	Lead	Carbon	Silicon	Carbon
50	Quantum dots are particles	semiconductor	conductor	insulator	optical	semiconductor
	Larger QDs emit longer wavelengths resulting					
51	in emission colors such as	yellow	orange or red	brown	black	orange or red
	Smaller QDs emit shorter wavelengths			blue and	green and	
52	resulting in colors like	brown	red and orange	green	yellow	blue and green
		Carbon	Atomic	Small		
53	Nanotechnology, in other words, is	engineering	engineering	technology	Microphysics	Atomic engineering
	The diameter of the nano wire is about					
54		10-6m	10-3m	10-8m	10-9m	10-9m
	A suspended nano wire is a wire that is			Low vaccum	High vaccum	
55	produced in the	Air medium	Vaccum	chamber	chamber	High vaccum chamber
56	Nano wires are used in	Transistors	Resistors	Capacitors	Transducers	Transistors
	Nano cones are the predominant structures					
57	made with	Carbon	Nitrogen	Hydrogen	Silicon	Carbon



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DEPARTMENT OF PHYSICS

UNIT II (Objective Type/Multiple choice Questions each Questions carry one Mark)

NANOMATERIALS AND APPLICATIONS

S.No.	QUESTIONS	opt1	opt2	opt3	opt4	ANSWER
			Chemical			
	Which of the following uses radio frequency		vapour	Sol-gel	Electro	
1	to produce nano-particles?	Plasma arching	deposition	technique	deposition	Plasma arching
				Chemical		
	Which of the following methods can be used		Sol-gel	vapour	Mechanical	Chemical vapour
2	to produce nano-powders of oxides?	Plasma arching	technique	deposition	crushing	deposition
		Chemical				
	Which of the following is used to make both	vapour	Sol-gel		Electro	
3	nano-particles and nano-powders?	deposition	technique	Plasma arching	deposition	Sol-gel technique
	Which method can be used to prepare iron	Pulsed laser	Sol-gel	Electro-	Mechanical	
4	nitriles nano-crystals using ammonia gas?	deposition	technique	deposition	crushing	Mechanical crushing
	Which of the following is used to modify the					
5	optical properties of a material system?	Electricity	Magnetic field	Pressure	Light	Light
	Which of the following is used in electro optic	Lithium	Barium sodium	Lithium	Lithium	
6	modulators?	tantalite	niobate	niobate	sodium niobate	Lithium niobate
7	Sol-gel method is approach	Bottom up	Up bottom	Top down	Down top	Bottom up
8	Sol-gel method is known since	1970	1960	1980	1990	1980
	Which ratio decides the efficiency of		Surface			
9	nanosubstances?	Weight/volume	area/volume	Volume/weight	Pressure/volume	Surface area/volume

10 temperature is above 1000oC 1500oC 2000oC 2500oC 200 11 The set get is a set of set id particle Sublimation Malting Get down Colloidal	2000oC Colloidal suspension
11 The sel cellis a statistic Sublimation Melting Cool down Cool	Colloidal suspension
11 The sel gal is a final of solid particle Sublimation Malting Supersion Coal down	Colloidal suspension
<u>11 The sol-get is a</u> of some particle. Submination Micruing Suspension Cool down Co	
Heavy	
12 The gel is a mass. molecular Semi regid Regid Light molecular Sem	Semi regid
13 Sol-gel method is chemical process. Dry Wet Semi liquid Semi solid We	Wet
undergo hydrolysis and poly	
14 condensation reactions. Metal ions Metal carbonates Metal nitrates Metal oxides	Metal oxides
The solvent evolves towards the formation of	
an inorganic continuous network containing a Semi solid	
15 Gaseous phase Gel Solid phase phase Ge	Gel
Formation of an inorganic continuous network	
16containing the metal centres withAzoOxoNitroHydroOz	Oxo
After drying process the liquid phase is	
removed from the gel and is	
17 performed. Calcination De-oxygenation Oxygenation Hydrogenation Ca	Calcination
One of the advantages of sol-gel method is	~
18 able to get uniform andpowder. Micro size Large size Nano size Small size Sm	Small size
Non uniform	
Sol-gel method can produce Uniform multi Non uniform Multi multi	Uniform multi
19 systems. component multi-component component component component	component
Metal nano particularly	
20 Institute a frequencies are prepared	0.11
20 by the chemical reduction method. Silver Gold Platnum Tungsten Sil	Silver
and citrate solution are used	
21 method Somi corbozono Hudrozino Hudrozono Somi corbozono H	Undrazina hudrata
Z1 Incurod. Inyurazine Inyurazine Inyurazine What is range of temperature at Hydro thermal	Tryutazine nyutate
22 reservoirs? 350°C 210°C 50°C 1900°C 35	35000
ZZ Reservents: Stoce Zroce Stoce Stoce Stoce When the When the When the area is When water When With the stoce	When water has
movement of prone to volcanic has access to temperature on acc	access to high
23 When do hydrothermal resources arise? tectonic plates eruntions high earth surface is ter	temperature

		occurs		temperature	very high	
	Fabrics are extensively made out of nano	Carbon nano				
24	materials like	tubes	Fullerenes	Mega tubes	Polymers	Fullerenes
		DC and very	DC and high	AC and very	AC and high	C and very low
25	The power required for electro-deposition is	low voltage	voltage	low voltage	voltage	voltage
	The energy required for refining of gold in					
26	kWh / tone is about	100 to 150	250 to 350	300 to 350	350 to 400	300 to 350
	On industrial scale sodium metal is prepared					
27	by electrolysis of fused	NaOH	NaCl	NaO	NH3	NaCl
					5	
			stannous	hydrogen	sodium	
28	Electrolyte used for tin plating is	sulphide ore	sulphate	sulphate	chloride	stannous sulphate
	When zinc is plated on steel, anode is made up					
29	of	steel	oxygen	zinc	carbon	zinc
	If the container of ball mill is more than half					
30	filled, the efficiency of milling is	increased	reduced	same	zero	reduced
	mass ratio of balls to material					
31	is advisable	3:01	4:01	2:01	1:01	2:01
	If surface area of liquid is large then				none of	
32	evaporation will be	small	large	moderate	above	large
	Changing of a liquid into vapours from					
33	surface of liquid without heating it is called	expansion	contraction	evaporation	fusion	evaporation
24	Evaporation from surface of any liquid	4 4		nature of	- 11 - C - 1,	- 11 - f - 1,
34	depends on	temperature	Wind	nquia	all of above	all of above
				increase in	increase in	
35	Evaporation causes	cooling	heating effect	weight	density	cooling

				In between		
				freezing point		
		freezing	1 1 1	and boiling	at all	. 11
36	Evaporation takes place at	point	boiling point	point	temperatures	at all temperatures
	Lithography was invented by in	Alois				
37	1/98.	Senetelder	John Denver	Manuel Neuer	Billy Armstrong	Alois Senefelder
	The surface is treated with a that					
20	is soaked into the image area, but avoided the	D 1 1		C'11	D	
38	H2O treated, non-image area.	Polar ink	Non-polar ink	Silk screen	Pressure screen	Non-polar ink
		Process used to	D 1.			
		transfer a	Process used to	Process used		D 1.
		pattern to a	develop an	to develop a	D 1/	Process used to
20	T table of the first	layer on the	oxidation layer	metal layer on	Process used to	transfer a pattern to a
39	Litnography is:	Discontinution	on the chip	the chip	produce the chip	layer on the chip
40	The system utilised to apply the H2O solution	Dissociating	Dampening	H2O hating	T 144 autor	
40	to the plate surface is called the	system	system	system	Littering	H2O hating system
	Dot gain in the mid tones is said to be about					
41	lower than with conventional	1.00/	200/	200/	400/	100/
41	ntnography.	1070	20%	SU70	40%	1070
12	Silicon ovide is not torned on a substrate using:	lithography	Dhotolithography	lithography	lithography	Dhotolithography
42	The chamical used for chielding the active	пшодгарну	Filotofftilography	Hydrofluoria	nnograpny	rnotonulography
13	areas to achieve selective oxide growth is:	Silver Nitride	Silicon Nitride	acid	Polycilicon	Silicon Nitride
	An is a sol with the continuous		Sincon Mulde	aciu		
	nhase a gas. Fog is an of water					
44	dronlets.	Aerosol	Emulsion	Agglomerate	Electrophoresis	Aerosol
	An is a sol in which the suspended	11010001	Linubion			
	particles are liquid droplets and the continuous					
45	phase is also a liquid. The 2 phases are	Aerosol	Emulsion	Agglomerate	Electrophoresis	Emulsion

	immiscible, otherwise a solution would form.					
46	A is a sol of solid particles scattered in a liquid. Foam is a colloidal system in which gas bubbles dispersed in a liquid or solid.	Colloidal suspension	Streaming potential	Sedimentation potential	Electrophoresis	Colloidal suspension
47	The of colloids are of maximum importance since the interaction of the particles with each other and the principal phase is of primary concern.	Magnitude	Shape	Surface	Size	Surface
48	As the concentration increases to the critical micelle concentration(C.M.C.) soap particles abruptly collected into spherical structures called	Ball	Sphere of ions	Micelles	Dirt particle	Micelles
49	is the charged field generated by charged particles moving in a stationary liquid.	Colloidal suspension	Emulsion	Sedimentation potential	Electrophoresis	Sedimentation potential
50	When tiny particles of a substance are dispersed through medium then mixture is called	alloys	amalgams	suspension	colloid	colloid
51	Particle size in suspension is	less than 10^3 nm	10 ² nm	greater than 10^3	10 nm	less than 10 ³ nm
52	What is the best description of blood?	sol	foam	solution	aerosol	sol
		Agitation is provided only by bubbles leaving the	The tube bundle is arranged vertically, with the solution inside the tubes	To handle viscous solution a pump is used	Also called	Agitation is provided only by bubbles
53	Which of the following is a characteristic of a horizontal tube evaporator?	evaporator as	condensing	to force liquid	short vertical	leaving the evanorator as vapor
54	Which of the following is not an assumption in the evaporator model?	The feed has only one volatile	Only the latent heat of vaporization is	Boiling action in heat exchanger	Overall temperature driving force is	Overall temperature driving force is the temperature that of

	components	available for	ensures perfect	the temperature	saturated steam
		heating the	mixing	that of saturated	
		solution		steam	



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DEPARTMENT OF PHYSICS

UNIT III (Objective Type/Multiple choice Questions each Questions carry one Mark)

NANOMATERIALS AND APPLICATIONS

S.No.	QUESTIONS	opt1	opt2	opt3	opt4	ANSWER
		Scanning	Scientific	Systematic		Scanning
		Tunneling	Technical	Technical	Super Tensile	Tunneling
1	The full form of STM is	Microscope	Microscope	Microscope	Microscope	Microscope
2	What does 'F' stand for in AFM?	Fine	Front	Force	Flux	Force
	X-rays have larger wavelengths than which of the					
3	following?	Gamma rays	Beta rays	Microwave	Visible light	Gamma rays
			They are			
			electromagnetic	Their		Their
		They have very high	radiation, and	wavelengths are	Their high	wavelengths
		energy, hence they	hence do not	comparable to	frequency	are comparable
	X-ray diffraction patterns are used for studying	can penetrate through	interact with	inter-atomic	enables rapid	to inter-atomic
4	crystal structure of solids because	solids	matter (crystals)	distances	analysis	distances
	For destructive interference to take place, the path					
5	difference between the two waves should be:	nλ	2nλ	$(n+1/2)\lambda$	$(2n+1)\lambda$	nλ
	Minimum interplanar spacing required for Bragg's					
6	diffraction is:	λ/4	$\lambda/2$	λ	2λ	$\lambda/2$
			normal to	parallel lattice	normal to	parallel lattice
	In Bragg's equation $[n\lambda = 2.d.\sin\theta]$, θ is the angle	specimen surface	specimen surface	surfaces d	parallel lattice	surfaces d
7	between:	and incident rays	and incident rays	distance apart	surfaces d	distance apart

				and incident rays	distance apart and incident rays	and incident rays
	In the powder method of XRD, the intensities of					
	various bright lines are compared to determine the					
	crystal structure. For simple cubic lattice the ratio					
8	of intensities at first two maxima are:	1/2	3/4	1/4	1	1/2
	X-ray diffractometers are not used to identify the			Polymeric		
9	physical properties of which of the following?	Metals	Liquids	materials	Solids	Liquids
	X-ray diffractometers provide				Either	
	information about the compounds present in a			Quantitative and	quantitative or	Quantitative
10	solid sample.	Quantitative	Qualitative	qualitative	qualitative	and qualitative
	Using powder method of diffractometers, which of		Percentage of Na+	Percentage of	Percentage of	Percentage of
11	the following can be determined?	Percentage of K+	and Cl-	KBr and NaCl	Br-	KBr and NaCl
						Thin walled
	In powder method, the powder sample is	Thin walled glass	Thin walled test	Thin walled	Thin walled	glass capillary
12	contained in which of the following?	capillary tubes	tube	curvettes	flask	tubes
	Which of the following is the most common					
	instrument for photographic recording of	Debye-Scherrer			Scintillation	Debye-Scherre
13	diffraction patterns?	powder camera	Gamma camera	Geiger tube	counter	powder camera
	With the help of which of the following equations					
	is the distance calculated from known wavelength				Scherrer	Bragg's
14	of the source and measured angle?	Coolidge equation	Bragg's equation	Debye equation	equation	equation
	In Diffractometer, the identification of a					
	component of the sample from its powder					
	diffraction pattern is based upon the of				Position,	Position,
15	lines and their relative	Number, length	Number, intensity	Position, length	intensity	intensity
	Diffractometers are similar to which of the	Optical grating	Prism		Photovoltaic	Optical grating
16	following?	spectrometer	spectrometer	Photo multiplier	cell	spectrometer
	In Diffractometers, line intensities depend on					
	and kind of atomic reflection centres in				Distance	
17	each set of plates.	Number	Position	Length	between lines	Number
	In powder diffractometer, the sharpness of the	Quality of the	Quality of the slit,	Thickness of the	Number of	Quality of the
18	lines is greatly determined by which of the	sample, size of the	size of the sample	slit, amount of	slits,	slit, size of the

following? slit the sample composition of the sample sample X-Rays are magnetic radiation radiation electroir radiations chemical radiations chemical radiations chemical radiations electromagnetic radiations chemical radiations electromagnetic radiations chemical radiations electromagnetic radiations electromagnetic radiations compound microscope electron microscope transmissio electron microscope compound microscope transmissio electron microscope 20 Electrons of Seanning Electron Microscope are 21 glass funnel specimen metal-coate surfaces vacuum ehamber metal-coate surfaces 22 Magnification of light microscope is 1500X 2000X 1000X 2500X 1500X 23 known as 0bject can be magnified under electron microscope about 350, 000 times 250, 000 times 300, 000 450, 000 300, 000 25 Flectron Microscope can give a magnification up to o 400,000X 100,000X 1500X 100X 400,000X 26 Icetron beams imagnetic fields imagnetic fields inght vspass through	 						
X-Rays aremagnetic radiationclectric radiationelectromagnetic radiationshermical radiationsclectromagnetic radiations19Kind of clectron microscope which is used to study internal structure of cells isscanning clectron microscopetransmission electron microscopelight microscopecompound microscopetransmission electron microscope20Electrons of Scanning Electron Microscope are reflected throughglass funnelspecimenmetal-coated surfacesvacuum chambermetal-coate surfaces21Magnification of light microscope is known as1500X2000X1000X2500X1500X20Photograph which is taken from microscope is known as1500X2000X1000X2500X1500X24Microscope about350, 000 times250, 000 times250, 000timeselectron heams and magnetic fields25microscope?electron beams electron beamsmagnetic fieldslight wavesspecimen should be thin and dry, image is obtained on phosphorescent screen and electron beamspecimen should be thin and dry, image is obtained on o hposphorescent screen and electron beamspecimen should be thin and dry, image is obtained on phosphorescent screen and electron beam must pass throughspecimen should be thin and dry, image is obtained on phosphorescent screen and electron beams must pass throughspecimen should be thin and dry, image is obtained on phosphorescent screen and electron beams must pass th		following?	slit		the sample	composition of the sample	sample
Kind of electron microscope which is used to study internal structure of cells isscanning electron microscopetransmission electron 	19	X-Rays are	magnetic radiation	electric radiation	electromagnetic radiations	chemical radiations	electromagnetic radiations
Electrons of Scanning Electron Microscope are reflected throughglass funnelspecimenmetal-coated surfacesvacuum chambermetal-coate surfaces21Magnification of light microscope is Nnown as1500X2000X1000X2500X1500XPhotograph which is taken from microscope is ancorgaphmacrographmonographmicrographpictographmicrograph0bject can be magnified under electron 	20	Kind of electron microscope which is used to study internal structure of cells is	scanning electron microscope	transmission electron microscope	light microscope	compound microscope	transmissior electron microscope
22Magnification of light microscope is Photograph which is taken from microscope is known as1500X2000X1000X2500X1500X23Photograph which is taken from microscope is known asmacrographmonographmicrographpictographmicrograph24Object can be magnified under electron microscope about350, 000 times250, 000 times300, 000 times450, 000 times300, 000 times25microscope aboutelectron beams and magnetic fieldselectron beams and magnetic fieldselectron beams and magnetic fieldselectron beams and magnetic fieldselectron beams and magnetic fieldselectron beams and magnetic 	21	Electrons of Scanning Electron Microscope are reflected through	glass funnel	specimen	metal-coated surfaces	vacuum chamber	metal-coated surfaces
23Photograph which is taken from microscope is known asmacrographmonographmicrographpictographmicrograph0Object can be magnified under electron aricroscope about350,000 times250,000 times300,000 times450,000300,000 	22	Magnification of light microscope is	1500X	2000X	1000X	2500X	1500X
24Object can be magnified under electron microscope about350,000 times250,000 times300,000 times450,000 times300,000 times24microscope aboutwhich of the following is used in electron microscope?electron beams electron beamselectron beams and magnetic fields25microscope?electron beamsmagnetic fieldslight waveselectron beams fields26to400,000X100,000X15000X100X400,000X26to400,000X100,000X15000Xspecimen should be thin and dry, image is obtained on a phosphorescent screen and clectron beamspecimen should be thin and dry, image is obtained on a phosphorescent screen and evacuated evacuatedelectron beam evacuated evacuated evacuated evacuatedspecimen streen and evacuated evacuated chamberspecimen should be thin and dry, image is obtained on a phosphorescent screen and evacuated evacuatedmicroscope is a function ofmicroscope is a function ofmicroscope is a function of28microscope is a function ofelectron beam used that lie in the mass of atomsnumber of atoms that lie in themass of atoms that lie in the	23	Photograph which is taken from microscope is known as	macrograph	monograph	micrograph	pictograph	micrograph
Which of the following is used in electron microscope?electron beams electron beamsmagnetic fieldselectron beams and magnetic fieldselectron beams and magnetic fields26toElectron Microscope can give a magnification up 26400,000X100,000X15000X100X400,000X26to400,000X100,000X15000X100X400,000X27microscop?specimen specimen stould be thin and dry specimen screen andspecimen screen and electron beam screen and electron beam screen and electron beam screen and electron beamspecimen should be thin and dry, image is obtained on a phosphorescent screen and electron beam27microscopy?specimen thin and dry wavelength of microscopy is a function ofspecimen should be thin and drymicroscope is a function ofnumber and mass of atomsmass of atomsnumber and mass of atoms	24	Object can be magnified under electron microscope about	350, 000 times	250, 000 times	300, 000 times	450, 000 times	300, 000 times
26 to	25	Which of the following is used in electron microscope?	electron beams	magnetic fields	light waves	electron beams and magnetic fields	electron beams and magnetic fields
Image is obtained is obtained on a phosphorescent microscopy?specimen should be thin should be thin and dry, image is obtained on a is obtained on phosphorescent phosphorescent phosphorescent phosphorescentspecimen should be thin and dry, image is obtained on a is obtained on phosphorescent phosphorescent phosphorescentspecimen should be thin and dry, image 	26	Electron Microscope can give a magnification up to	400,000X	100,000X	15000X	100X	400,000X
28 microscope is a function of electron beam used that lie in the mass of atoms that lie in the mass of atoms	27	Which of the following are true for electron microscopy?	specimen should be thin and dry wavelength of	image is obtained on a phosphorescent screen	electron beam must pass through evacuated chamber number and	specimen should be thin and dry, image is obtained on a phosphorescent screen and electron beam must pass through evacuated chamber mass of atoms	specimen should be thin and dry, image is obtained on a phosphorescent screen and electron beam must pass through evacuated chamber
	28	microscope is a function of	electron beam used	that lie in the	mass of atoms	that lie in the	mass of atoms

			electron path	that lie in the	electron path	that lie in the
				electron path		electron path
						Scanning
	Which among the following helps us in getting a	Transmission	Scanning Electron	Compound	Simple	Electron
29	three-dimensional picture of the specimen?	Electron Microscope	Microscope	Microscope	Microscope	Microscope
	The secondary electrons radiated back in scanning			vacuum		
30	microscope is collected by?	specimen	anode	chamber	cathode	anode
					size and	size and
					chemical	chemical
					composition of	composition of
					the irradiated	the irradiated
					object, number	object, number
					of electrons	of electrons
					ejected and on	ejected and on
					the number of	the number of
			chemical		electrons	electrons
	On what factors do the intensity of secondary	shape of the	composition of the	number of	reabsorbed by	reabsorbed by
31	electrons depends upon?	irradiated object	irradiated object	electrons ejected	surrounding	surrounding
	Where do we obtain the magnified image of the		phosphorescent		scanning	cathode ray
32	specimen in SEM?	cathode ray tube	screen	anode	generator	tube
					Negative-	Negative-
					Staining,	Staining,
					Shadow	Shadow
					Casting,	Casting,
	Which of the following techniques are used in				Ultrathin	Ultrathin
	Transmission Electron Microscopy (TEM) for			Ultrathin	Sectioning,	Sectioning,
33	examining cellular structure?	Negative-Staining	Shadow Casting	Sectioning	Freeze-Etching	Freeze-Etching
	In Electron microscope, light source is replaced by	electron	neutron	nroton	nhoton	electron
34	a beam of very fast moving	electron	neution	proton	photon	ciccuon
	Electrons are sub-atomic particles that rule outer	photon	narticle	atom	molecule	atom
35	part of the	Photon	Particle	atom		
	When maintaining the microscope what is used to					
36	clean the lenses?	Oil	Water	Alcohol	Detergent	Alcohol
37	What device is used to test the optics of the high	Stage magnometer	Stage micrometer		Glass slide	Stage

	power lens			Haemocytometer		micrometer
				Oil the		
	When maintaining the microscope, which is NOT	Clean off grease and		mechanics and	Wash the base	Wash the base
38	an essential step?	spills	Blow away dust	moving parts	and arm	and arm
	Which of the following components on a light				Revolving	The two eye
39	microscope should be focused first?	The two eye pieces	Objective lenses	Condenser	nosepiece	pieces
	Which of these objectives should be used to first					
40	view the specimen?	X10	X40	X4	X100	X4
	What is the correct name for the main microscope					
41	lens that focuses the image?	Ocular	Binocular	Objective	Condenser	Objective
	What is the correct name for the microscope lens					
42	located in the eyepiece?	Ocular	Binocular	Objective	Condenser	Ocular
	If the eyepiece magnification on light microscope					
	is $x10$ and the objective is $x40$, what is the overall					
43	magnification?	x10	x40	x400	x4	x400
			transmission			transmission
	Kind of electron microscope which is used to	scanning electron	electron	light	compound	electron
44	study internal structure of cells is	microscope	microscope	microscope	microscope	microscope
	Electrons of Scanning Electron Microscone are			metal-coated	Vacuum	metal-
45	reflected through	glass funnel	specimen	surfaces	chamber	coated surfaces
	Object can be magnified under electron		specificit	300,000	450,000	300,000
46	microscope about	350, 000 times	250_000 times	times	times	times
10			250,000 times		By calibration	
	How is the wavelength controlled in an FTIR	By a Michelson			with a standard	
47	spectrometer?	Interferometer	By a computer	By a laser	sample	By a laser
		A dispersive	An emission	An absorbance	A UV-Vis	An absorbance
48	What type of technique is FTIR spectroscopy?	technique?	technique	technique	technique	technique
			I I	The same as that		
	What does the spectrum of Nitrogen(N2) look	The same as that of	It has only p- and	of carbon	It doesn't have	It doesn't have
49	like?	air	r-branches	monoxide	one!	one!
	What occurs when the moving mirror in an FTIR					
	spectrometer is the same distance from the	Constructive	Destructive	Radio	The spectrum	Constructive
50	beamsplitter as the static mirror?	interference	interference	interference	is measured	interference

Γ					Between the		Between the
				Between the	visible and	Between the	visible and
		In what region of the spectrum does infrared	At the low-energy	visible and	microwave	visible and x-	microwave
	51	radiation occur?	end	ultraviolet regions	regions	ray regions	regions
		What occurs when a molecule absorbs infrared				It vibrates	It vibrates
	52	radiation?	It warms up	It flies around	It spins faster	faster	faster
			•	It is useful where	Size has been	Size has	Size has
		Which of the following is not true about Fourier	It is of non-	repetitive analysis	reduced over the	increased over	increased over
	53	Transform Infrared (FTIR) spectrometer?	dispersive type	is required	years	the years	the years
ſ				Information could			
		Which of the following is not the advantage of	Signal to noise ratio	be obtained on all	Retrieval of data	Easy to	Easy to
	54	Fourier Transform Spectrometers?	is high	frequencies	is possible	maintain	maintain
ſ		In which region of the electromagnetic spectrum		•			
	55	does an absorption at 600 nm come?	Vacuum-UV	Visible	near UV	infrared	Visible
			The shifting of an				
			absorption towards				
			the blue end of the			The shifting of	
			spectrum	The shifting of an	The shifting of	an absorption	The shifting of
				absorption to	an absorption to	to shorter	an absorption
	56	What is a red shift?		higher energy.	lower energy	wavelength	to lower energy
		Why is the computer necessary in Fourier	To display the	To process the	To determine the	To determine	To process the
	57	Transform Spectrometer?	detector output	detector output	amplitude	the frequency	detector output
		What is the wavelength range for UV spectrum of			0.01 nm to 10	10 nm to 400	10 nm to 400
	58	light?	400 nm - 700 nm	700 nm to 1 mm	nm	nm	nm
ſ		Which of the following has to be computed to		Ratio of sample			Ratio of sample
		determine transmittance and absorbance at various	Ratio of signal and	and reference		Reference	and reference
	59	frequencies?	noise	spectra	Sample spectra	spectra	spectra

Endle | Engleten | Enrich Endle | Engleten | Enrich EAGRAPAGAAN ACADEMO HEIGHEREDUCATION (Dezende to be University) (Established Under Sections of Udic Art, 1956)

KARPAGAM ACADEMY OF HIGHER EDUCATION

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DEPARTMENT OF PHYSICS

UNIT IV (Objective Type/Multiple choice Questions each Questions carry one Mark)

NANOMATERIALS AND APPLICATIONS

S.No.	QUESTIONS	opt1	opt2	opt3	opt4	ANSWER
	When the size of the material decreases, the					
1	band gap energy	increases	decreases	remains constant	zero	increases
	The Fermi energy of the metal are in the order					
2	of	5 MeV	5 eV	5 KeV	5 meV	5 eV
				Metal or		Metal or
	Quantum effects mainly occurs at			Semiconductors		Semiconductors
3		conductor	metal	Nanocrystal	insulator	Nanocrystal
	This Coulomb blockade behaviour is also	maxwell			Coulombic	
4	called as	staircase	quantized	ballistic	staircase	Coulombic staircase
	The dimension of the nanomaterials reduced			Metal or		
	to de-Broglie wavelength, the semiconductor			Semiconductors		
5	nanomaterials changes to	conductor	metal	Nanocrystal	insulator	insulator
	The size of the nanocrystal					
	than the de-Broglie wavelength,			Smaller,	Larger,	
6	energy levels formed	Smaller, Discrete	Larger, Discrete	continuous	continuous	Smaller, Discrete
	How does a semiconductor behave at absolute		protection			
7	zero?	conductor	device	Semiconductors	insulator	insulator
			Positive	Negative		Negative
	How is the resistance of semiconductor		temperature co-	temperature co-		temperature co-
8	classified?	High resistance	efficient	efficient	Low resistance	efficient

	The threshold for indirect absorption occurs at					
9	wavelength	3.01 µm	2.09 µm	0.92 μm	1.09 µm	1.09 µm
	The semiconductor material for which the					
10	lowest energy absorption takes place is :	GaAs	Silicon	GaSb	Germanium	Germanium
	materials are potentially					
11	superior to germanium.	GaAs	Silicon	GaSb	III – V alloys	III – V alloys
	If the absorption of electromagnetic radiation					
	by matter results in the emission of radiation					
	of same or longer wavelengths for a long or a					
	short time, the phenomenon is termed as				Spontaneous	
12	which of the following?	Luminescence	Fluorescence	Phosphorescence	emission	Luminescence
	Prompt emission of X-ray by an atom ionised					
	by a higher energy X-ray is a type of which of				Spontaneous	
13	the following phenomena?	Luminescence	Fluorescence	Phosphorescence	emission	Fluorescence
	In X-ray fluorescence spectrometer, the					
	relationship between the excitation intensity	Spectrum of the				
	and the intensity of fluorescence does not	incident	Angle of			
14	depend on which of the following?	radiation	radiance	Molecular weight	Incident angle	Incident angle
15	Fluorescence occurs within	10-5 s	10-5 ms	10-5 μs	10-5ns.	10-5 ms
	alloys can be fabricated					
16	in hetero-junction structures.	InGaSb	III – V alloys	InGaAsP	GaAsSb	III – V alloys
	The alloys lattice matched to InP responds to					
17	wavelengths up to $1.7\mu m$.	InAsSb	III – V alloys	InGaSb	InGaAs	InGaAs
	Which phenomenon is related to the term	magnetic		electromagnetic	none of the	
18	radiation?	phenomenon	gravity	phenomenon	above	
			the magnetic			
	Thermal radiation takes place from a body by	the weight of the	power of the	the temperature	none of the	electromagnetic
19	electromagnetic waves as a result of	body	body	of the body	above	phenomenon
				using shiny		
				white surfaces		
		increasing the		instead of dull	decreasing the	
	Rate of transfer of energy by radiation can be	surface	decreasing the	and black	atmospheric	the temperature of
20	increased by	temperature	surface area	surfaces	pressure	the body
21	Thermal energy that reaches surface of earth	Conduction	Convection	Radiation	Conduction and	increasing the

	from sun, is transferred through process of				convection	surface temperature
22	Which of the following is not an example of	Hydrophobic surface of a lotus	Hydrophylic surface of a	Sticky pads on the bottom of an	Gold that can stretch to form flexibile	Gold that can stretch to form
		plain			Scanning	
23	Which of the following is used to observe the unseen?	Hydrophobocity Microscopes	Magnetos	Atomic Force Tunnelers	Tunneling Microscopes	Scanning Tunneling Microscopes
24	Nano wires are used in	Transistors	Resistors	Capacitors	Transducers	Transistors
25	Nano cones are the predominant structures made with	Carbon	Nitrogen	Hydrogen	Silicon	Carbon
26	As per Coulomb's law, force of attraction or repulsion between two point charges is directly proportional to	sum of the magnitude of charges	square of the distance between them	product of the magnitude of charges	cube of the distance	product of the magnitude of charges
	Electric charges under action of electric forces	U		U	electric field	6
27	is called	electrostatic	electric flux	electric field	lines	electrostatic
28	The absorption of photons in a photodiode is dependent on:	Absorption Coefficient α0	Properties of material	Charge carrier at junction	Amount of light	Absorption Coefficient α0
29	The absorption coefficient of semiconductor materials is strongly dependent on	Properties of material	Wavelength	Amount of light	Amplitude	Wavelength
30	In optical fiber communication, the only weakly absorbing material over wavelength band required is:	GaAs	Silicon	GaSb	Germanium	GaSb
31	The threshold for indirect absorption occurs at wavelength	3.01 µm	2.09 µm	0.92 μm	1.09 µm	1.09 µm
32	The semiconductor material for which the lowest energy absorption takes place is :	GaAs	Silicon	GaSb	Germanium	Germanium
33	photodiodes have large dark currents.	GaAs	Silicon	GaSb	Germanium	GaSb
34	A photodiode should be chosen with a less than photon energy.	Direct absorption	Band gap energy	Wavelength range	Absorption coefficient	Absorption coefficient
35	materials are potentially superior to germanium.	GaAs	Silicon	GaSb	III – V alloys	III – V alloys

	alloys can be fabricated					
36	in hetero-junction structures.	InGaSb	III - V alloys	InGaAsP	GaAsSb	III – V alloys
	alloys such as InGaAsP and					
37	GaAsSb deposited on InP and GaSb substrate.	Ternary	Quaternary	Gain-guided	III – V alloys	Ternary
	The alloys lattice matched to InP responds to					
38	wavelengths up to 1.7µm.	InAsSb	III – V alloys	InGaSb	InGaAs	InGaAs

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DEPARTMENT OF PHYSICS

UNIT V (Objective Type/Multiple choice Questions each Questions carry one Mark)

NANOMATERIALS AND APPLICATIONS

S.No.	QUESTIONS	opt1	opt2	opt3	opt4	ANSWER
	Process of emission of electrons from hot metal	plastic	thermionic		current	thermionic
1	surfaces is called	emission	emission	static emission	emission	emission
		attractive		repulsive		
	At room temperature, electron cannot escape	forces of	repulsive forces	forces of	pulling force of	attractive forces of
2	metal surface due to	nucleus	of electrons	nucleus	protons	nucleus
	One of the applications of Bulk micromachining			Temperature		
3	is :	SAW sensor	Resonant sensor	sensor	Pressure sensor	Resonant sensor
				Micro-electro		Micro-electro
	method removes material through erosive	Diamond		discharge		discharge
4	action:	milling	Soft lithography	machining	Powder blasting	machining
	Which of the following are the three most widely	Bulk, surface,	Surface, bulk,	PMMA, LIGA,	LIGA, CMP,	
5	used micromachining processes	PMMA	LIGA	surface	surface	Surface, bulk, LIGA
	Which of the following MEMS components					
	would LEAST likely be fabricated using bulk		Microfluidic			
6	micromachining processes?	Cantilevers	channels	Probes	Gear trains	Gear trains
	Photoresist is to surface micromachining as				Plexiglas or	
7	is to LIGA.	Beryllium	Gold	КОН	PMMA	Plexiglas or PMMA
		To improve	Aid the FBI for	Improve the		To improve
	Which choice below best describes the goal for	technology for	investigative	application of	Increase food	technology for
8	nanotechnology advances in medicine?	finding cures	methods	cosmetics	production	finding cures



					Larger and	
	What can nanotechnology best help with for	Produce	Reduce the size	Make stuff	stronger	Reduce the size of
9	consumer products?	floating devices	of devices	light up	materials	devices
	Why are nanoelectronic devices a less expensive		They require		They are more	
	alternative to the design of current electronic	They are slower	less parts and	They are less	vulnerable to	They require less
10	devices?	operating	materials	reliable	viral software	parts and materials
	The components fabricated using surface					
	micromachining are aspect ratio					
	components relative to other micromachining					
11	processes.	Low	medium	high	ultra high	Low
12	Particles emitted from hot cathode surface are	negative ions	positive ions	protons	electrons	electrons
	One of the most used kinds of lasers in		Diamond	Bulk		
13	microfabrication is:	Excimer	milling	micromachining	Pressure sensor	Excimer
	Which of then following is example of direct					
14	access?	magnetic disc	floppy disc	program tape	plain disc	magnetic disc
				To produce		
		The price of a		more silicon		To produce more
	Interest of increasing wafer diameter from 200	300 mm wafer	It is easier to	devices from a	To increase the	silicon devices from
15	mm to 300 mm	is lower	fabricate	single wafer	size of a die	a single wafer
				the reciprocal	the reciprocal	
	If a single walled CNT is semiconducting, the	the value of	the square value	value of	square value of	the reciprocal value
16	bandgap scales with	diameter, d	of diameter, d2	diameter, 1/d	diameter, 1/d2	of diameter, 1/d
17	The term photo voltaic comes from	spanish	greek	german	english	greek
18	The term photo voltaic is in use since	1840	1844	1849	1850	1849
	When the source of light is not sun light then the		Photo voltaic		Photo	
19	photo voltaic cell is used as	Photo diode	cell	Photo detector	transmitter	Photo detector
	Solar cells are made from bulk materials that are					
20	cut into wafer of thickness	120-180µm	120-220µm	180-220µm	180-240µm	180-240µm
	photo voltaic devices in the form of	Cadmium		Cadmium	Cadmium	Cadmium
21	thin films.	Telluroide	Cadmium oxide	sulphide	sulphate	Telluroide
		Copper Indium			Copper Indium	
		Gallium		Copper Gallium	Gallium	Copper Indium
22	is a direct band gap material	Selenide	Copper Selenide	Telluride	Diselenide	Gallium Selenide

	Dye-sensitized solar cells are made from	Ruthium				
23	organic dye.	melallo	Aniline	Safranine	Induline	Ruthium melallo
24	Quantum dot solar cells are based on	Gratzel cell	Solar cell	Voltaic cell	Galvanic cell	Gratzel cell
25	The quantum dot used are	CdS	CdTe	PbO	GaAs	CdTe
	the cathode and the anode of the diode are	emitter and				emitter and
26	referred to as	collector	electrode	terminals	connections	collector
	entering the structure from the					
27	emitter is described by the wavefunction	proton	electron	neutron	photon	electron
28	the lifetime of an electron in the well equals	5 x 10-12s	5 x 10-12μs	5 x 10-12ms	5 x 10-12ns	5 x 10-12s
29	The widths of the quantum wells are equal to	36 Å	46 Å	56 Å	66 Å	46 Å
	The heights of the barriers vary from			0.3 eV to 1.2	0.3 eV to 1.2	
30		0.3 eV to 1.2 V	0.3 eV to 1.2 eV	mV	MeV	0.3 eV to 1.2 eV
	For asymmetric barriers, the maximum					
31	transmission at $E \perp = \epsilon n$ is	positive	unity	less than unity	negative	less than unity
		sequential	quantum		1:00	
	The process responsible for the resonant-	tunneling	tunneling	tunneling	differential	sequential tunneling
32	tunneling effect is the so-called	process	process	process	process	process
22	For the lower temperature, there is			: 4	-1	-1
33	current at finite voltage blases	positive	negative	unit	almost zero	almost zero
	As of public record at the end of 2002, which					
	investment in melecular penetechnology					
3/	research?	Russia	Ianan	China	India	Ianan
54	What is the term used in the field of	Russia	Japan	China	India	Japan
	nanotechnology to describe an as-vet theoretical					
	device that "will be able to bond atoms together					
35	in virtually any stable pattern?"	Stacker	Replicator	Assembler	Constructor	Assembler
	What is the general name for the class of		•			
36	structures made of rolled up carbon lattices?	Nanorods	Nanotubes	Nanosheets	Fullerrods	Nanotubes
37	The efficiency of the solar cell is about	25%	15%	40%	60%	15%
38	The output of the solar cell is of the order	0.1W	1W	10W	100W	1W
	What is the maximum possible output of a solar					
39	array?	300 W/m2	100 W/m2	250 W/m2	500 W/m2	250 W/m2

	The current density of a photo voltaic cell ranges	10 - 20	40 - 50	20 - 40	60 - 100	
40	from	mA/cm2	mA/cm2	mA/cm2	mA/cm2	40 - 50 mA/cm2
	Optical switching can be classified into					
41	categories.	Two	Three	Four	One	Two
	are the array of switches		Optical cross		Optical	Optical cross
42	which forms circuit switching fabrics.	Packet arrays	connects	Circuit arrays	networks	connects
					Disability to	
		Regenerating			handle burst	Disability to handle
43	What is the main disadvantage of OCS?	mechanism	Optical session	Time permit	traffic	burst traffic
	How many functions are performed by an optical					
44	packet switch?	4	3	2	1	4
	provides data storage for packets					
45	to resolve contention problems.	Switching	Routing	Buffering	Reversing	Buffering
	provides efficient designation,					
	routing, forwarding, switching of traffic through	Label	Multiprotocol	Optical		Multiprotocol label
46	an optical packet-switched network.	correlation	label switching	correlation	Routing	switching
	mode is temporary, selective and				Circuit	
47	continuous.	Cell switching	Buffer switching	Cache	switching	Circuit switching
	refers to the process whereby a					
	node finds one or more paths to possible					
48	destinations in a network.	Routing	Framing	Lightning	Cloning	Routing